# PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENCE

## **CONVEYING PARTY DATA**

Name	Execution Date
Ohio State University	08/06/2004

#### **RECEIVING PARTY DATA**

Name:	National Science Foundation	
Street Address:	4201 Wilson Blvd.	
Internal Address:	rm 1265	
City:	Arlington	
State/Country:	VIRGINIA	
Postal Code:	22230	

#### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	10313431

## **CORRESPONDENCE DATA**

Fax Number: (703)292-9041

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 703-292-8060
Email: sbattle@nsf.gov
Correspondent Name: Robin C. Fritsch
Address Line 1: 4201 Wilson Blvd.

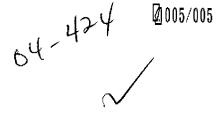
Address Line 2: rm 1265

Address Line 4: Arlington, VIRGINIA 22230

NAME OF SUBMITTER: R. Fritsch

Total Attachments: 1 source=001 (2)#page1.tif

PATENT REEL: 018412 FRAME: 0235



# License to the United States Government

Sign and Fax this to (301) 480-0272

Invention Title: Direct, Low Frequency Capacitance Measurement For Scanning Capacitance Micros
Inventor(s): Jonathan Pelz
Bharat Bhushan
David Lee

02ID59F AND 6218101-02-0001 U.S. Filing/Issue Date: 12/05/02

Patent or Application Serial No.: 10/313,431

Grant/Contract Number(s): NSF CMS-0001382 & DMR-0074416

Foreign Applications filed/intended in (countries): PCT/US03/17234; Full Designation; 06/02/03

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above Identified grant or contract award from the United State Government. This document is confirmatory of:

 The nonexclusive, nontransferable, irrevocable, paid-up license to practice or have practiced for or on behalf of the United States the invention described in any patent application and in any and all divisions, continuations, and continuations in part, and in any and all patents and re-issues granted thereon throughout the world; and

 All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations that are applicable to the award.

The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this day of
(Name of Grantee/Contractor Official)  Suc Contractor Official)  (Signature)
Title Dicector, Technology Licensing
For The Ohio State University
(Grantee/Contractor Organization)
At 1960 Kenny Rd
Columbus OH 43210

PATENT REEL: 018412 FRAME: 0236

**RECORDED: 10/19/2006** 

(Business Address)